

Pressure Regulators for Plasma Systems

DESCRIPTION:

Plasma cutting systems require gas input to create the plasma gas and shield gas flows. Most gases are available in both high pressure cylinders and in liquid form. Certain gas mixtures are only available in high pressure cylinders. Please check with your local gas supplier for availability.

Park Industries offers Dual-Stage high pressure cylinder regulators to insure constant delivery pressure over the life of the cylinder.

FEATURES:

Gas	Delivery range	CGA fitting
Oxygen	Up to 200 PSIG	CGA 540, 9/16-18 RH
Nitrogen	Up to 200 PSIG	CGA 580, 5/8-18 RH
Argon	Up to 200 PSIG	CGA 580, 5/8-18 RH
Hydrogen	Up to 200 PSIG	CGA 350, 9/16-18 LH
Nitrogen-Hydrogen (95%/5%)	Up to 200 PSIG	CGA 350, 9/16-18 LH)
Argon-Hydrogen (65%/35%)	Up to 200 PSIG	CGA 350, 9/16-18 LH

